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OCT 20 2004

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: S. SUNDAR KUMAR IYER, ET AL. )  
Serial No.: 09/878,556 ) Group Art Unit: 2813  
Filed: June 11, 2001 ) Examiner: Chen, J.  
For: METHOD OF FORMING VARIABLE )  
OXIDE THICKNESS ACROSS ) Confirmation No.: 3210  
SEMICONDUCTOR CHIPS )

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Final Office Action mailed September 7, 2004, please amend  
the Application as follows:

DO NOT Enter  
10/27/04  
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